

Form PTO-1449								ATTY DOCKET NO. 3672-0109P				APPLICATION NO. 09/720,084																																																								
<b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b> (Use several sheets if necessary)												APPLICANT EBBESSEN, et al.																																																								
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<b>OTHER DOCUMENTS</b> (Include Name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.																																																																				
JH ↓		G. HOROWITZ, "Organic Field-Effect Transistors" Advanced Materials, Vol. 10, pp. 365-377; (1998)																																																																		
		D. PEDE et al., "A General-Purpose Conjugated-Polymer Device Array for imaging" Advanced Materials, Vol. 10, pp. 233-237 (1998)																																																																		
↓		R.H. FRIEND, et al., "Electroluminescence in Conjugated Polymers", Nature 397, pp. 121-128 (1999).																																																																		
		J.G. BLAKE, et al., "Low-temperature polysilicon reshapes FPD production", Solid State Technology, pp. 151-161 (May 1997)																																																																		
↓		J.R. HEATH, et al., "A Defect-Tolerant Computer Architecture: Opportunities for Nanotechnology", Science, Vol. 280, pp. 1716-1721 (June 12, 1998).																																																																		
		H. YABE, et al., "Direct writing of conductive aluminum line on aluminum nitride ceramics by transversely excited atmospheric CO2 laser", APL 71 pp. 2758-2760 (1997).																																																																		
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